

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/549,865

First Named Inventor: Victor Higgs  
Filed: July 28, 2006

Title: Detection Method and Apparatus Metal Particulates on Semiconductors

TC/A.U. 2886 Examiner: Isiaka O. Akanbi  
Atty Docket: NAN165 US (8037) Confirmation No.: 4772

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Saratoga, California  
February 3, 2009

Mail Stop After Final  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

This Response to Office Action is responsive to the December 3, 2008, final Office Action, which has a statutorily shortened period for response that ends March 3, 2009. The Commissioner is hereby authorized by the undersigned to debit Deposit Account 50-2263 for any underpayment or any additional necessary fees.

The present response makes no amendments and does not require any additional search or new consideration.

**Claims:** the current status of the claims is reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

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